

Figure 1. SEM images showing the influence of high frequency power on the etching of grayscale microlenses (left to right: 500W, 1000W, 1500W)

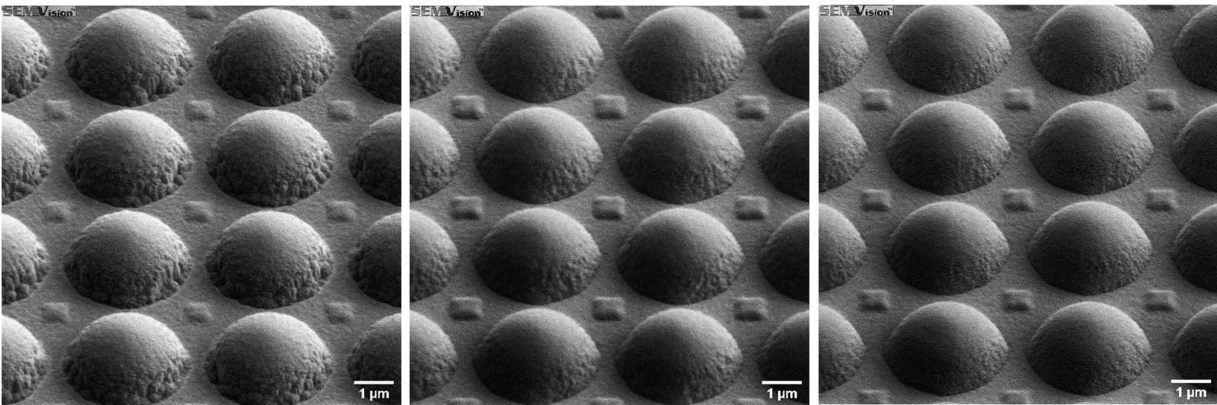


Figure 2. SEM images showing the influence of chuck temperature on the etching of grayscale microlenses (left to right: 10°C, 30°C, 50°C)